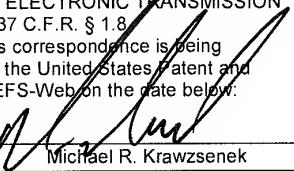


PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Title: HIGH INDEX AND HIGH IMPACT RESISTANT POLYTHIOURETHANE/UREA MATERIAL, METHOD OF MANUFACTURING SAME AND ITS USE IN THE OPTICAL FIELD

Appl. No.: 09/992,054
Applicants: Jallouli *et al.*
Filed: November 14, 2001
TC/A.U.: 1796
Examiner: Sergent, Rabon A
Docket No.: ESSR:058US
Customer No.: 32425
Confirmation No. 4850

CERTIFICATE OF ELECTRONIC TRANSMISSION 37 C.F.R. § 1.8	
I hereby certify that this correspondence is being electronically filed with the United States Patent and Trademark Office via EFS-Web on the date below.	
March 17, 2009 Date	Michael R. Krawzenek 

RESPONSE TO OFFICE ACTION DATED DECEMBER 17, 2008

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant submits this Response to the Office Action mailed December 17, 2008 ("the Action"), which is due on March 17, 2009. No fees are believed due in connection with this filing. However, should any fees be due; the Commissioner is authorized to deduct any such fees required under 37 C.F.R. §§ 1.16 to 1.21 from Fulbright & Jaworski Deposit Account No. 50-1212/ESSR:058US.

Amendments to the Claims are reflected in the listing of claims which begins on page 2.

Remarks/Arguments begin on page 9.